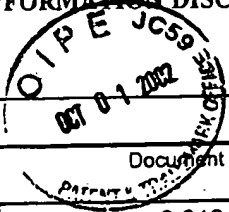
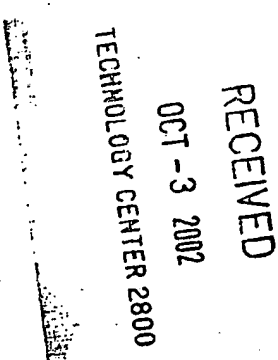
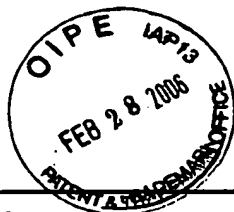


Form PTO-1449 (Rev. 8-83)		Department of Commerce Patent and Trademark Office		Atty Docket 0756-2		Serial No. 09/542,473	
INFORMATION DISCLOSURE STATEMENT 				Applicants: Takayuki IKEDA			
				Filing Date: April 04, 2000		Group Art Unit: 2826	
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)	
AS	6,013,929	01/11/2000	Ohtani				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
Examiner Initial							
AS	Specifications and Drawings for Application Serial No. 08/862,895, "Semiconductor Intergrated Circuit and Fabrication Method Thereof", Filing Date: May 23, 1997, Inventor: Hisashi OHTANI						
	Specifications and Drawings for Application Serial No. 09/468,859, "Thin Film Transistor, Method of Manufacturing the Same, and Semiconductor Device Including the Same" Filing Date: December 21, 1999, Inventor: Hisashi OHTANI						
	Specifications and Drawings for Application Serial No. 09/487,432, "Semiconductor Device and Process for Production Thereof" Filing Date: January 19, 2000, Inventors: Shunpei YAMAZAKI et al.						
↓	Specifications and Drawings for Application Serial No. 09/493,411, "Semiconductor Device and Method of Fabricating the Same" Filing Date: January 28, 2000, Inventors: Shunpei YAMAZAKI et al.						
							
Examiner /A Sefer/				Date Considered 05/05/2006			
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							



Substitute for form 1449A/PTO		Complete if Known			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	09/542,473		
		Filing Date	April 4, 2000		
		First Named Inventor	Takayuki Ikeda et al.		
		Art Unit	2826		
		Examiner Name	Ahmed Sefer		
Sheet	1	of	1	Attorney Docket Number	740756-2138

U.S. PATENT DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
		Country Code ³ Number ⁴ Kind Code ² (if known)				

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	AS	Shiroh INUI et al.; "Thresholdless Antiferroelectricity in Liquid Crystals and its Application to Displays"; Journal of Materials Chemistry; 1996; Vol. 6, No. 4, pp. 671-673.	

Examiner Signature	/A Sefer/	Date Considered	05/05/2006
-----------------------	-----------	--------------------	------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.